

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>		Application Number <u>10/663,001</u> Not Yet Assigned		Inventor Martin Schmidt et al		
		Title OPERATING-MICROSCOPE SYSTEM				
		Filing Date <u>9/16/03</u> Not Yet Assigned		Group Art Unit <u>2872</u> Not Yet Assigned		Docket Number GMH/409/US
UNITED STATES PATENT DOCUMENTS						
EXAMINER # INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<u>W07</u>	5,704,900	01/1998	Dobrovolny et al.	600	229	
<u>N07</u>	2002/0026096 A1	02/2002	Motoki et al.	600	146	
FOREIGN PATENT DOCUMENTS						
Examiner Initial	DOCUMENT NUMBER	DATE MO/DAY/YR	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<u>W07</u>	DE 23 19 215	1973	Germany	—	—	X
<u>W07</u>	DE 43 11 467 A1	1994	Germany	—	—	X
<u>W07</u>	DE 195 21 060 A1	1996	Germany	—	—	X
<u>W07</u>	DE 196 32 281 A1	1997	Germany	—	—	X
<u>W07</u>	DE 196 40 907 A1	1997	Germany	—	—	X
<u>W07</u>	2001-46399	2001	Japan	—	—	X
OTHER DOCUMENTS <small>(Including Author, Title, Date, Pertinent Pages, Etc.)</small>						
		International Search Report EP 02 02 0833, Dated 12 December 2002.				
<u>W07</u>		Patent Abstract of Japan, Title: Microscopic Device For Operation, Publication No. 2001046399, Dated 20-02-2001.				
<u>W07</u>		Patent Abstract of Japan, Title: System Controller, Publication No. 2002125219, Dated 26-04-02.				
EXAMINER				DATE CONSIDERED <u>10/5/05</u>		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						